



AF/2811  
JFW

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:  
Wen-Ting Chu, et al.

Confirmation Number: 4121

Serial No.: 09/846,536

Group Art Unit: 2811  
Examiner: Nadav, Ori

Filed: May 2, 2001

TKHR Docket No. 252016-1190  
Top-Team Ref. 0503-5741US

For: **A NOVEL SELF-ALIGNED, LOW CONTACT RESISTANCE VIA FABRICATION  
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**Certificate of Mailing**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop AF; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 29, 2004.

  
Signature – Hui Chin Barnhill

**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

Mail Stop AF  
Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The final Office Action mailed October 6, 2004 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.